



ABSTRACT:

The present invention relates to the substrate assembling apparatus which ensures lamination between the upper and lower substrates under vacuum even when said
5 substrates have one and the same profile.

In the substrate assembling apparatus according to the present invention, two substrates to be laminated are placed face to face with each other, and two substrates are laminated with each other by sealing material attached
10 to any one of the substrate. Two substrates are held face to face with each other in the vertical direction under vacuum, and the upper substrate is released to fall down on the lower substrate, thereby allowing lamination of both substrates.